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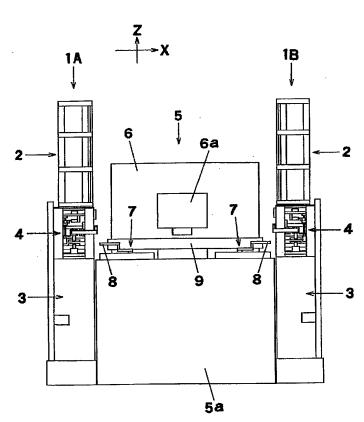
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(54) Title: APPARATUS OF SUPPLYING AND CONTAINING MICRO-PLATE, METHOD OF SUPPLYING AND METHOD OF CONTAINING MICRO-PLATE AND APPARATUS OF PROCESSING MICRO-PLATE



(57) Abstract: It is an object of the invention to provide an apparatus of supplying a micro-plate excellent in operating performance and operability. In a microplate supplying apparatus for separating micro-plates 10 mounted in a stacked state sheet by sheet to supply, a first stock portion 2, a second stock portion 3 for containing the micro-plates in the stacked state are arranged in series in an up and down direction by interposing a micro-plate take out and take in mechanism 4, the micro-plates 10 are moved from the first stock portion 2 to the second stock portion 3 while staying in the stacked state, the micro-plate at a uppermost stage of the plurality of micro-plates 10 is disposed at a micro-plate carry out level L2, and the micro-plate is taken out by a micro-plate carrying out mechanism to supply to a working apparatus 5. Thereby, the micro-plate is set in an excellent operation attitude and the micro-plate can stably be taken out.

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